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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	)	
	)	Docket No. LAM1P111.CIP
Stephan E. LASSIG et al.	)	
	)	Examiner: N. M. Barreca
Application No. 10/644,269	)	
	)	Group Art Unit: 1756
Filed: August 19, 2003	)	
	)	Date: April 26, 2006
For: METHOD FOR PATTERNING A	)	
LAYER OF A LOW DIELECTRIC	)	Confirmation No. 7489
CONSTANT MATERIAL	)	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 26, 2006.

Signed:

*Diane Schwanbeck*  
Diane Schwanbeck

ELECTION OF CLAIMS FOR PROSECUTION ON THE MERITS

Commissioner for Patents  
Post Office Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants submit this paper in response to the Office Action dated March 31, 2006. In response to the restriction requirement, Applicants hereby elect claims 1-3, 6-13, 16, 17, and 20-22 (the Group I claims) for prosecution on the merits.

If any fees are due to effect consideration of this paper, then the Commissioner is authorized to charge such fees to Deposit Account No. 50-0805 (Order No. LAM1P111.CIP).

Respectfully submitted,  
MARTINE PENILLA & GENCARELLA, LLP

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